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Bib Data Sheet

CONFIRMATION NO. 1903

<b>SERIAL NUMBER</b> 10/001,483	<b>FILING DATE</b> 11/01/2001 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812 <i>2823</i>	<b>ATTORNEY DOCKET NO.</b> TI-31133
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**APPLICANTS**  
Antonio L. P. Rotondaro, Dallas, TX;

**\*\* CONTINUING DATA \*\*\*\*\***  
THIS APPLN CLAIMS BENEFIT OF 60/247,408 11/10/2000 *me*

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***  
*none me*

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED**  
**\*\* 01/25/2002**

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY TX	SHEETS DRAWING 4	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after				
Verified and Acknowledged Examiner's Signature <i>Michelle L. L. L.</i> Initials				

**ADDRESS**  
23494

**TITLE**  
Method to improve the uniformity and reduce the surface roughness of the silicon dielectric interface

<b>FILING FEE RECEIVED</b> 870	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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